

Spring Meetings

April 16 - 21, 1990
San Francisco,
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PAPERS

Abstract
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C.J. Brinker, Sandia National Laboratories, (505) 846-3552, FAX (505) 846-5064; D.E. Clark, University of Florida, (904) 392-7660, FAX (904) 392-6359; Donald R. Ulrich, Air Force Office of Scientific Research, (202) 767-4963; Brian J.J. Zelinski, Arizona Materials Laboratories, (602) 322-2977, FAX (602) 322-2993

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HIGH RESOLUTION ELECTRON MICROSCOPY OF DEFECTS IN MATERIALS

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ALLOY PHASE STABILITY AND DESIGN

G. Malcolm Stocks, Oak Ridge National Laboratory, (615) 574-5163; Anthony F. Giamei, United Technologies Research Center, David P. Pope, University of Pennsylvania, (215) 898-9837, FAX (215) 898-1130

THIN FILM STRUCTURES AND PHASE STABILITY

Bruce M. Clemens, Stanford University, (415) 725-7455, FAX (415) 725-4034; William L. Johnson, California Institute of Technology, (818) 356-4433, FAX (818) 795-1547

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David C. Paine, Brown University, (401) 863-1457, FAX (401) 863-1157; John C. Bravman, Stanford University, (415) 723-3698, FAX (415) 725-4034

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Jeffrey A. Kelber, Sandia National Laboratories, (505) 844-5436; Ralph G. Nuzzo, AT&T Bell Laboratories, (201) 582-5486; Matthew V. Tirrell, University of Minnesota, (612) 625-0192, FAX (612) 626-7246; Ernesto Occhiello, Istituto Guido Donegani, Italy

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Michael A. Schluter, AT&T Bell Laboratories, (201) 582-3106; Murray S. Daw, Sandia National Laboratories, (415) 294-2198

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Donald L. Anton, United Technologies Research Center, (203) 727-7174, FAX (203) 727-7879; Robert McMeeking, University of California, Santa Barbara, (805) 961-4583, FAX (805) 961-8124; Daniel Miracle, United States Air Force, Wright-Patterson AFB, (513) 255-9833, FAX (513) 255-9792; Patrick Marlin, Los Alamos National Laboratory, (505) 667-8168, FAX (505) 667-1754

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Theodore H. Geballe, Stanford University, (415) 723-0215, FAX (415) 723-0010; Ping Sheng, Exxon Research & Engineering, (201) 730-2870, FAX (201) 730-3042; G.D. Cody, Exxon Research & Engineering, (201) 730-3022; FAX (201) 730-3042

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Merrilea J. Mayo, Sandia National Laboratories, (505) 846-3551, FAX (505) 846-5064; Jeffrey Wadsworth, Lockheed Missile & Space Co., Inc., (415) 424-2234, FAX (415) 354-5415; Masaru Kobayashi, Technological University of Nagasaki, Japan, 0258-46-6000, Ext. 7120, FAX 0258-46-6972; Amiya K. Mukherjee, University of California at Davis, (916) 752-1776; FAX (916) 752-8058

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WORKSHOP ON SPECIMEN PREPARATION FOR TRANSMISSION ELECTRON MICROSCOPY OF MATERIALS II

Ron Anderson, IBM, (914) 892-2225, FAX (914) 892-2555

FRONTIERS OF MATERIALS RESEARCH

Robert A. Huggins, Stanford University, (415) 723-4110, FAX (415) 725-4034

FERROELECTRIC THIN FILMS

Angus I. King, North Carolina State University, (919) 737-2347, FAX (919) 737-3419; Edward R. Myers, National Semiconductor, (408) 721-2258, FAX (408) 736-8503

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Meeting Chairs

John C. Bravman
Stanford University
(415) 723-3698
FAX (415) 725-4034

William H. Butler
Oak Ridge
National Laboratory
(615) 574-4845
FAX (615) 574-7721

C. Jeffrey Brinker
Sandia National
Laboratories
(505) 846-3552
FAX (505) 846-5064